



**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

**In re Application of:**

Farnworth et al.

**Serial No.:** 09/923,687

**Filed:** August 6, 2001

**For:** HERMETIC CHIP AND METHOD OF  
MANUFACTURE

**Examiner:** F. Toledo

**Group Art Unit:** 2823

**Attorney Docket No.:** 2269-2741.5US  
(95-0804.04/US)

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**CERTIFICATE OF MAILING**

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**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

This amendment is in response to the Office Action of December 16, 2003 whose initial period of response is set to expire on March 16, 2004.

A listing of **claims** begins on page 2 of this paper.

**Remarks/Arguments** begin on page 6 of this paper.